Electronic Acknowledgement Receipt				
EFS ID:	1393486			
Application Number:	10567248			
International Application Number:				
Confirmation Number:	3061			
Title of Invention:	Method for fluorescene lifetime imaging microscopy and spectroscop			
First Named Inventor/Applicant Name:	Javier A. Jo			
Customer Number:	50670			
Filer:	Scott W. Kelley/Jody Cohan			
Filer Authorized By:	Scott W. Kelley			
Attorney Docket Number:	67789-536			
Receipt Date:	21-DEC-2006			
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Application Type:	U.S. National Stage under 35 USC 371			

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1		49278_POA_SB81_and_Sta tement_SB96.pdf	639233	yes	2

Multipart Description/PDF files in .zip description		
Document Description	Start	End
Power of Attorney	1	1
Assignee showing of ownership per 37 CFR 3.73(b).	2	2

Warnings:

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.